

INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Not for submission under 37 CFR 1.99)	Application Number		10/585,004	
	Filing Date		06/28/2006	
	First Named Inventor	Erik Enebakk		
	Art Unit	1792		
	Examiner Name	Hiteshew		
	Attorney Docket Number	E-1068		

U.S.PATENTS						
Examiner Initial*	Cite No	Patent Number	Kind Code ¹	Issue Date	Name of Patentee or Applicant of cited Document	Pages, Columns, Lines where Relevant Passages or Relevant Figures Appear
/F.H./	1	4247528	X	1981-01-27	Vishu D. Dosaj et al.	all
/F.H./	2	5972107	A	1999-10-26	Frederick Schmid et al.	all

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/F.H./	1	20010020438	A	2001-09-13	Keigo Hoshikawa et al.	all

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/F.H./	1	1338682	EP	A	2003-08-27	Hemlock Semiconductor Corporation	all	<input type="checkbox"/>
/F.H./	2	02099166	WO	A	2002-12-12	SINTEF	all	<input type="checkbox"/>

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/F.H./	1	Ciszek T. F. et al., "Alternative Solar-Grade Silicon Feedstock Approaches" NREL Conference Paper, The NCPV Program Review Meeting, Lakewood, Colorado, 14.-17. October 2001	<input type="checkbox"/>
/F.H./	2	Australian Research Council, University of New South Wales, "Third Generation Photovoltaics 2002 Annual Report"	<input type="checkbox"/>
/F.H./	3	Tsou Y.S. et al., "Environmentally Benign Silicon Cell Manufacturing", World Conference and Exhibition on Photovoltaic Solar Energy Conversion, 6.-10. July 1998, Vienna Austria	<input type="checkbox"/>
/F.H./	4	von Keitz A. et al., "Improvement of Low Cost Ceramic Substrates for Use in Thin Film Silicon Solar Cells", World Conference and Exhibition on Photovoltaic Solar Energy Conversion, 6.-10. July 1998, Vienna Austria	<input type="checkbox"/>
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